

Electronic Patent Application Fee Transmittal

Application Number:	10823347			
Filing Date:	12-Apr-2004			
Title of Invention:	Gas diffusion shower head design for large area plasma enhanced chemical vapor deposition			
First Named Inventor/Applicant Name:	Soo Young Choi			
Filer:	Keith M. Tackett/Nyweli Houston			
Attorney Docket Number:	APPM/8657/DISPLAY/AKT/RKK			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Submission- Information Disclosure Stmt	1806	1	180	180
Total in USD (\$)				180